

Application/Control No.	Applicant(s)/Patent under Reexamination
10/625,584	UZELAC ET AL.
Examiner	Art Unit
James K. Trujillo	2116

	SEARCHED				
Class	Subclass	Date	Examiner		
713	300,320, 323,324	12/29/2004	JKT		
327	143	12/29/2004	JKT		
326	83	12/29/2004	JKT		
Updated		5/25/2005	JKT		

INT	INTERFERENCE SEARCHED				
Class	Subclass	Date	Examiner		
	4.				

SEAR(INCLUDING SE	CH NOTES EARCH STRATEGY)
	DATE	EXMR
Databases: East NPL: IEEE, ACM See attached	12/29/2004	JKT
Updated	5/25/2005	JKT
•		